Interface stoichiometry control to improve device voltage and modify band alignment in ZnO/Cu2O heterojunction solar cells

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The interface stoichiometry of cuprous oxide (Cu2O) was controlled by adjusting the O2 and Zn partial pressures during ZnO sputter deposition and measured by high-resolution X-ray photoelectron spectroscopy of ultrathin (<3 nm) ZnO films on Cu2O. Open-circuit voltage measurements for ZnO/Cu2O heterojunctions under AM1.5 illumination were measured and it was found that a stoichiometric interface can achieve the voltage entitlement dictated by the band alignment, whereas the non-stoichiometric interface showed large open-circuit voltage deficits. These results highlight not only the need for stoichiometric interfaces in Cu2O devices, but also a reproducible experimental method for achieving stoichiometric interfaces that could be applied to any potential heterojunction partner. Additionally, valence-band offset measurements indicated changing the interface stoichiometry shifted the band alignment between Cu2O and ZnO, which accounts for the variation in previously reported band offset values.

Introduction

Cuprous oxide (Cu2O) is a promising alternative to traditional thin-film photovoltaic materials (CIGS, CdTe, a-Si, etc.) because of its low materials cost, the abundance of its component elements in the earth’s crust,3 and its uniquely straightforward processing.4–6 Crystalline wafers of Cu2O can be fabricated directly by thermal oxidation of Cu foils, making manufacturing high quality photovoltaic materials possible through low-cost processing.5,6 Furthermore, Cu2O has an electronic band gap of 2.1 eV which gives it a detailed balance efficiency of ~20% for a homojunction solar cell and also the potential for an independently connected Cu2O/Si tandem device with an efficiency of ~43%.3,5,6,7 It is an intrinsic p-type semiconductor with relatively high absorbance in the visible region above the gap.5 Finally, minority carrier diffusion lengths of 10 μm and hole mobilities of up to 100 cm2 V−1 s−1 have also been reported for Cu2O made by thermal oxidation.5,6,8

Despite band gap and minority carrier properties that are favorable for achieving a high energy conversion efficiency, the highest efficiency achieved in a photovoltaic device with a Cu2O absorber layer is 5.38%.9 There are several challenges to making a Cu2O photovoltaic device, including an inability to dope the material,5,10 its relatively low chemical stability compared to other oxides,11 and a lack of suitable heterojunction partners due to an unusually small electron affinity.12 We have focused on the low chemical stability, namely the fact that Cu2O is an especially reactive oxide due to its low enthalpy of formation (ΔHf° = −168.7 kJ mol−1). The low value of the heat of formation means Cu2O will be reduced when in contact with nearly any elemental material. Cu forms a low barrier Schottky diode with Cu2O, thus the presence of interfacial Cu lowers the photovoltaic cell’s built-in voltage. The effect of interfacial Cu on device performance has been well characterized for Cu2O Schottky diodes...
devices.\textsuperscript{2,13} However Cu is not the only species that may reactively form at the interface as copper has another stable oxide, CuO.\textsuperscript{14} The effect of interfacial CuO has not been studied explicitly in Cu$_2$O heterojunctions, and its specific impact on device performance is unknown.

We have chosen to study the ZnO/Cu$_2$O interface because it has been the most widely studied Cu$_2$O based heterostructure, and until recently, the most efficient heterojunction system as well.\textsuperscript{2,13–22} In this manuscript, we describe the controlled modification of ZnO/Cu$_2$O heterostructures to yield stoichiometric interfaces as well as nonstoichiometric interfaces with Cu and CuO present. We also show that stoichiometric interfaces are necessary for achieving large device voltages. The ZnO/Cu$_2$O interface stoichiometry and valence-band alignments were measured experimentally by high-resolution X-ray photoelectron spectroscopy (XPS). Finally, in order to quantify the effect of local deviations in interface stoichiometry, ZnO/Cu$_2$O photovoltaic devices of varying interface composition were tested under AM1.5 1-sun solar illumination.

**Results and discussion**

**a. Determination of ZnO/Cu$_2$O and Zn/Cu$_2$O interface stoichiometry by X-ray photoelectron spectroscopy**

In order to measure the interface stoichiometry, we performed XPS on thin heterointerfaces (Fig. 1). Due to the surface sensitivity of XPS, film thicknesses were constrained to less than the escape depth of photo-excited electrons (~3 nm). This allowed analysis of the heterojunction stoichiometry without the need for sputter depth profiling, leaving pristine interfaces free of crystalline damage.

X-ray photoelectron spectroscopy is a particularly powerful technique for Cu$_2$O stoichiometry determination because CuO, Cu$_2$O and elemental Cu can be differentiated by analyzing high-resolution XPS spectra of the Cu 2p\textsubscript{3/2} (Cu 2p) and Cu Auger (Cu a) peaks.\textsuperscript{21} If Cu is bound as CuO, the Cu 2p\textsubscript{3/2} peak shifts to slightly higher binding energy. However this one peak is not sufficient to understand the oxidation state of the Cu at the interface since Cu$_2$O and elemental Cu have the same Cu 2p\textsubscript{3/2} peak position. Elemental Cu can be differentiated from Cu$_2$O by looking for peak shifts in the Cu Auger peak. Cu shifts to lower binding energies in the Auger peak while Cu$_2$O and CuO have the same peak position.

High-resolution XPS spectra (Fig. 2) were collected for different thicknesses of Cu$_2$O heterojunctions made with (Fig. 2a) O-rich ZnO, (Fig. 2b) Zn-rich ZnO, or (Fig. 2c) elemental Zn. The XPS spectra for the bare Cu$_2$O wafer (0.0 nm) shows a shoulder in the Cu 2p peak in all samples, indicating there is CuO on the surface of the wafer. This surface oxide forms when Cu$_2$O is exposed to atmosphere because CuO is the stable phase of copper oxide at room temperature and pressure.\textsuperscript{24} When O-rich ZnO is deposited onto the slightly oxidized Cu$_2$O surface (Fig. 2a), the shoulder in the Cu 2p peak continues through all thicknesses of ZnO. This result is expected since O-rich ZnO should have no elemental Zn available to react with the surface of the Cu$_2$O. Thus by depositing O-rich ZnO directly onto the slightly oxidized Cu$_2$O surface, we can produce a mixed phase surface with both CuO and Cu$_2$O.

When Zn-rich ZnO is deposited instead of O-rich ZnO (Fig. 2b) we expect the wafer surface to be reduced due to the availability of elemental Zn. The data shows that as Zn-rich ZnO is deposited onto Cu$_2$O the shoulder in the Cu 2p peak disappears, indicating that the CuO layer is reduced. Furthermore, analysis of the Cu Auger peak shows no Cu$_2$O is reduced since no low binding energy peak is present, thus the reaction terminates at the Cu$_2$O surface. The reaction appears to be highly selective, which could be due to the slightly higher formation enthalpy ($\Delta H_f^o$) of Cu$_2$O versus CuO.\textsuperscript{11} This reaction was also found to be highly reproducible and all deposited thicknesses showed the same trend. Thus depositing Zn-rich ZnO onto a slightly oxidized Cu$_2$O surface yields a stoichiometric ZnO/Cu$_2$O interface.

Elemental Cu was formed at the interface by sputtering elemental Zn onto Cu$_2$O (Fig. 2c) because it was found to be impossible to reduce Cu$_2$O to Cu by sputtering ZnO alone. This is probably due to the low thermodynamic driving force for Zn to reduce Cu$_2$O, as ZnO also has a fairly low enthalpy of formation.\textsuperscript{11} The Cu 2p data shows that Zn, similarly to Zn-rich ZnO, reduces the CuO on the surface. However, the Cu Auger peak shows a second lower binding energy peak indicating Cu is forming at the interface. Therefore, solely by altering the partial pressures of Zn and O$_2$ during deposition, we were able to create Cu$_2$O heterointerfaces that were stoichiometric, or had elemental Cu or CuO present at the interface.

**b. Measurement of valence-band offsets**

The valence-band offset for the ZnO/Cu$_2$O heterojunction has been widely studied with published values ranging from 1.7 to 2.8 eV.\textsuperscript{18–22} However, little attempt has been made to correlate...
the observed variation in the offset with deviations in interface stoichiometry. The ZnO/Cu2O valence-band offsets were determined for the stoichiometric and CuO-containing interfaces via the Kraut method using XPS.24 In short, the binding energy difference between the Cu 3s and Zn 3s core-levels was observed for thin ZnO/Cu2O interfaces. The bulk core-level to valence-band maximum energy differences for Cu2O and ZnO were determined by fitting the valence-band region of the respective photoelectron spectrum to an instrument-convolved valence-band density of states calculated by density functional theory. The details of this procedure have been reported previously to successfully determine the band alignment of II–VI materials with other earth abundant PV absorbers.25

We found the stoichiometric interface and the interface with CuO precipitates had valence-band offsets of 2.4 ± 0.1 eV and 2.0 ± 0.1 eV respectively (Fig. 3). This indicates that the presence of a CuO interfacial species changes the band energetics between Cu2O and ZnO. The modification of heterojunction band alignment with the insertion of an interfacial layer has been observed previously in III–V and II–VI material systems.26 The dependence of the band offset on interface composition, which in turn is dependent on the ZnO deposition conditions, is likely responsible for the large variation in reported offset values and emphasizes the need for improved control and understanding of the interface stoichiometry.

c. Open-circuit voltage of ZnO/Cu2O photovoltaic devices with different interface species

The open-circuit voltage of photovoltaic devices (Table 1) was used to evaluate the relationship between the interface stoichiometry and the electronic quality of ZnO/Cu2O heterojunctions. J–V measurements were performed for devices made with a stoichiometric interface, with CuO at the interface, and with Cu present at the interface. The data was collected under simulated AM1.5 1-sun solar illumination. We focused our analysis on device open-circuit voltage because it is more sensitive to interfacial and bulk defects than other J–V characteristics and is thus considered an appropriate measure of interface quality. The reported open-circuit photovoltages were averaged over a minimum of 9 tested devices. The device with the stoichiometric interface demonstrated the highest open-circuit voltages of 530 ± 4 mV. The devices fabricated with CuO and Cu inclusions at the interface had substantially lower average open-circuit voltages of 109 ± 11 mV and 347 ± 30 mV, respectively. The short-circuit current densities and efficiencies of all of the devices were limited by the resistivity ($\rho > 1500$ $\Omega$ cm) and thickness (~1 mm) of the Cu2O substrate, as indicated by the large slopes of the $J$–$V$ curves near the open-circuit voltage ($R_{OC}$).
Table 1  Current–voltage parameters for illuminated devices, with open-circuit photovoltages highlighted. The devices with stoichiometric interfaces showed the largest open-circuit photovoltages despite having less ideal band offsets. All values are averaged over a minimum of 9 devices.

<table>
<thead>
<tr>
<th>Photovoltaic device structure</th>
<th>Open-circuit voltage (meV)</th>
<th>Short-circuit current (mA cm⁻²)</th>
<th>Fill factor (%)</th>
<th>Slope around open-circuit voltage (Ω⁻¹)</th>
</tr>
</thead>
<tbody>
<tr>
<td>ZnO/Cu₂O</td>
<td>530 ± 4</td>
<td>0.69 ± 0.47</td>
<td>30.4 ± 3.85</td>
<td>1.1 × 10⁵ ± 1.8 × 10⁵</td>
</tr>
<tr>
<td>ZnO/Cu/Cu₂O</td>
<td>109 ± 11</td>
<td>0.46 ± 0.21</td>
<td>25.5 ± 3.85</td>
<td>1.2 × 10⁵ ± 6.9 × 10⁵</td>
</tr>
<tr>
<td>ZnO/Cu/O/Cu₂O</td>
<td>347 ± 30</td>
<td>1.41 ± 0.54</td>
<td>26.0 ± 0.56</td>
<td>7.05 × 10⁵ ± 2.3 × 10⁵</td>
</tr>
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Fig. 4 The 1-D Poisson equations were solved for a ZnO/Cu₂O junction in order to determine the voltage limits of the device. That the ideal built-in voltage and the measured open-circuit voltage are so close indicates the formation of a near perfect interface.

In order to understand the voltage limits of the stoichiometric devices we modeled the band bending at the ZnO/Cu₂O interface by solving the 1-D Poisson equations (Fig. 4). For this model we choose a Cu₂O doping level of 10¹⁴ cm⁻³ to reflect the majority carrier concentration of our thermally oxidized Cu₂O wafers under illumination. To calculate the carrier concentration in the ZnO, we made a conservative estimate of mobility in the sputtered thin film of 1 cm² V⁻¹ s⁻¹. We then used the measured resistivity of ~1 Ω cm to calculate a carrier concentration of 10¹⁸ cm⁻³. Solving the Poisson equation, we calculated a built-in voltage of 480 ± 100 meV. The error in the estimation comes from the error in the band offset calculation, which has a much larger effect than error in the doping estimates. The built-in voltage is the voltage drop across the space charge region at equilibrium and thus is the maximum achievable open-circuit voltage in an ideal device. That the open-circuit voltage and the built-in voltage are so close shows that the stoichiometric interface is approaching its voltage entitlement, meaning the interface is behaving ideally. Thus the stoichiometric device performance is limited solely by the heterojunction offset, and the large series resistance contribution of the undoped Cu₂O substrate. If stoichiometry is maintained at the interface and an emitter with a more favorable offset is found, we believe large voltages and high efficiencies are achievable in a Cu₂O device.

The open-circuit voltage observed for the Cu interface is in agreement with the expectation that a Cu/Cu₂O Schottky barrier is formed at the interface. The reactively formed Cu/Cu₂O interface has been explored previously, and the device photovoltages align well with the work of Olsen et al. and Assimos et al. It is well understood that the device voltage is limited by the small work function difference between Cu₂O and Cu metal, and our photovoltages are identical to those previously achieved in Cu/Cu₂O Schottky devices.

Analysis of the ZnO/CuO/Cu₂O devices is slightly less obvious, because according to the valence-band offset measurements, these devices should have a larger built-in voltage and open-circuit voltage than the stoichiometric interface devices. However, the opposite trend was observed from the device measurements. There are several possible reasons for this including increased recombination at the interface and Fermi level pinning due either to the low band gap of CuO (~1.2 eV) or an increased density of interface states. However, we believe the lower observed open-circuit voltage for the device with CuO at the interface is most likely due to the degenerate nature of CuO. It is difficult to make a rectifying contact to CuO, and its presence would make contact at the junction nearly ohmic. These results show the importance of controlling the emitter deposition conditions in order to control the heterojunction interfacial composition. Clearly, a stoichiometric CuO interface is desirable for obtaining improved PV device performance.

Conclusions

We have demonstrated the ability to tune the Cu oxidation state between CuO, Cu₂O, and Cu at the ZnO/Cu₂O interface with careful modification of the emitter deposition conditions. High-resolution XPS was used to accurately probe the interface stoichiometry as well as the band alignment between the two semiconductors. It was found that the presence of CuO at the interface causes a 0.4 eV shift in the valence-band offset between Cu₂O and ZnO, which could help explain the variation in literature values of the ZnO/Cu₂O valence-band offset. Furthermore, photovoltaic device performance of ZnO/Cu₂O heterojunctions was observed to depend strongly on interfacial composition. Stoichiometric interfaces demonstrated
significantly larger photovoltages under AM1.5 1-sun illumination. The control of interfacial chemistry demonstrated herein is directly transferable to other heterojunction systems incorporating a Cu2O absorber and should result in further improvements in solar conversion efficiency.

Experimental

The Cu2O wafers used in these experiments were grown by thermal oxidation of 500 μm copper foils (99.9999%, Alfa Aesar) in a tube furnace. The Cu foils were hung vertically from Cu wires on a quartz substrate holder during oxidation. The Cu substrates were heated to 950 °C under N2 flow and then oxidized for 24 hours at 1 Torr O2. The temperature and pressure were chosen because they are within the stability range of the Cu2O phase in the Cu–O phase diagram. The substrates were then cooled to room temperature under a N2 flow resulting in ~1 mm thick, phase pure Cu2O wafers with a lateral grain size on the order of ~1 mm2.

Heterostructures for XPS studies were fabricated by radio-frequency magnetron sputter deposition of Zn or ZnO directly onto an untreated Cu2O surface at room temperature. A compound ZnO target and a pure Zn metal target were used as sputtering sources. Zn or ZnO films were deposited at 100 W substrate power and a sputtering pressure of 5 mTorr. ZnO was sputtered under both a pure Ar atmosphere and a 0.25 mTorr partial pressure of O2 in Ar. The ZnO sputtered with O2 was O-rich as indicated by its resistivity (ρ > 1000 Ω cm), while the ZnO sputtered in pure Ar was Zn-rich (ρ ~ 1 Ω cm). Zn was sputtered only under a pure Ar atmosphere. For XPS samples, the thickness of deposited films ranged from 0.5–10 nm.

For photovoltaic device fabrication, each of the three interface types was made by depositing ~2 nm of ZnO or Zn, which were sputtered according to the three conditions outlined above, onto a ~1 mm thick, untreated Cu2O wafer. An additional 10 nm of ZnO sputtered in Ar was deposited onto all the samples and capped with 50 nm of sputtered Al-doped ZnO (AZO) followed by 100 nm of Sn-doped In2O3 (ITO) as a top electrical contact. A thick Au film was deposited on the Cu2O as a back electrical contact. Device area was approximately 3 mm2.

The surface stoichiometry and interface stoichiometry of thin ZnO/Cu2O samples were measured using a Kratos Ultra XPS system. The Al Kz line (1486.6 eV) was used as a monochromatic X-ray source and the excited photoelectrons were collected by a hemispherical analyzer at 0° from the surface normal. Low-resolution survey spectra were acquired between binding energies (B.E.) of 1–1200 eV. Higher-resolution, detailed scans (detection line width of <0.26 eV), were collected on individual XPS features of interest. The sample chamber was maintained at <2 × 10−9 Torr. Finally, current density vs. potential (J–V) measurements on the full PV devices were performed under AM1.5 1-sun illumination.

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Notes and references